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AMENDMENTS TO THE CLAIMS

 (Currently Amended) An apparatus for cryogenic treatments for use-in-the medical or paramedical field as well as for the cosmetic field, comprising;

a microapplicator having a bore diameter of 20 to 120 μm supplied with a gas flow from which all foreign particles bigger than 3 μm have been eliminated configured to provide a partly gaseous and partly liquid jet when supplied with a flow of a liquefied gas;

a removable cartridge for supplying said liquefied gas; and

a replaceable filter for eliminating foreign particles, wherein the filter and the cartridge are configured such that replacement of the cartridge with a new cartridge automatically leads to the replacement of the filter with a new filter.

- (Currently Amended) The apparatus of claim 1, additionally comprising a
 eartridge of wherein the cartridge comprises purified condensed gas from which all solid
 materials have been eliminated.
- (Currently Amended) The apparatus of claim 1, additionally comprising a
 cartridge containing wherein the cartridge comprises N₂O.
- (Currently Amended) The apparatus of claims 1, wherein the microapplicator comprises a replaceable filter is arranged to retain particles superior to 3 μm.
- 5. (Currently Amended) The apparatus of claim 4, wherein the microapplicator-comprises—a replaceable filter is arranged to retain particles between 1 and 100 µm in function of the said bore diameter.
- 6. (Previously Presented) The apparatus of claim 4, wherein the filter is located in or on the microapplicator.
- 7. (Previously Presented) The apparatus of claim 1, wherein the microapplicator consists of a synthetic material or a resin to reduce the phenomena of icing and the clogging-up of said microapplicator.
 - (Previously Presented) The apparatus of claim 1 further comprising:
 a pipe;
 - a flow regulator for regulation of the flow in the said pipe; and

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> a valve, said valve being disposed perpendicularly to said pipe between said device and the said microapplicator and having three distinct possible positions under the effect of a mechanical or electrical control, comprising:

> a first position where a longitudinal pipe is created, which allows the flow of gas from the device to the microapplicator;

a second position where the gas flow is blocked; and

a third position which permits to the gas present in the cartridge to escape.

9. (Previously Presented) A process for interrupting a gaseous flow in a medical device, comprising:

providing a cylindrical valve comprising a transverse pipe which permits gas flow from a cartridge to a microapplicator, said valve being perpendicular to the direction of the gas flow; and

providing a mechanical or electrical actuator to permit upward and downward movement of said valve and providing O-rings for imperviousness.

- (Previously Presented) The process of claim 9, wherein the cylindrical valve comprises a vent, which allows escape of residual gas.
- (Currently Amended) A microapplicator for the apparatus of claim 1, wherein the imeroapplicator microapplicator comprises a mounted the removable filter.
- 12. (Previously Presented) A method for cosmetic treatment and/or dermatological treatment of the skin, comprising use of the apparatus of Claim 1.
- 13. (Previously Presented) A method for gynaecological or urological treatment, comprising use of the apparatus of claim 1.
- 14. (Previously Presented) The apparatus of claim 1, wherein all foreign particles bigger than 1 µm have been eliminated from the gas flow.
- $15. \quad \text{(Currently Amended)} \qquad \text{The} \quad \text{apparatus} \quad \text{of} \quad \text{claim} \quad 1, \quad \text{wherein} \quad \text{the} \\ \text{microapplicator-comprises-a the replaceable filter is arranged to retain particles larger than 1 } \mu \text{m}.$
- 16. (Currently Amended) The apparatus of claim 4, wherein the microapplicator-comprises a the replaceable filter is arranged to retain particles between 3 and 60 μ m in function of the said bore diameter.

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17. (Previously Presented) The apparatus of claim 7, wherein said synthetic material is a polycarbonate.

- (Previously Presented) The apparatus of claim 7, wherein said resin is

 PEEK.
- 19. (New) The apparatus of claim 1, wherein the removable filter is configured to eliminate all foreign particles bigger than 3 μm from the flow of liquefied gas supplied to the microapplicator.
- 20. (New) The apparatus of Claim 1, wherein the bore diameter is between 35 and 80 $\,\mu m$.